


Article

Black Phosphorus-Molybdenum Disulfide Hetero-Junctions Formed with Ink-Jet Printing for Potential Solar Cell Applications with Indium-Tin-Oxide

Ravindra Ketan Mehta ¹ and Anupama Bhat Kaul ^{1,2,*} 

¹ Department of Materials Science and Engineering, PACCAR Technology Institute, University of North Texas, Denton, TX 76203, USA; ravindramehta@my.unt.edu

² Department of Electrical Engineering, University of North Texas, Denton, TX 76203, USA

* Correspondence: anupama.kaul@unt.edu

Abstract: In this work, we implemented liquid exfoliation to inkjet-print two-dimensional (2D) black phosphorous (BP) and molybdenum disulfide (MoS₂) p–n heterojunctions on a standard indium tin oxide (ITO) glass substrate in a vertical architecture. We also compared the optical and electrical properties of the inkjet-printed BP layer with that of the MoS₂ and the electrical properties of the mechanically exfoliated MoS₂ with that of the inkjet-printed MoS₂. We found significant differences in the optical characteristics of the inkjet-printed BP and MoS₂ layers attributed to the differences in their underlying crystal structure. The newly demonstrated liquid exfoliated and inkjet-printed BP–MoS₂ 2D p–n junction was also compared with previous reports where mechanically exfoliated BP–MoS₂ 2D p–n junction were used. The electronic transport properties of mechanically exfoliated MoS₂ membranes are typically better compared to inkjet-printed structures but inkjet printing offers a cost-effective and quicker way to fabricate heterostructures easily. In the future, the performance of inkjet-printed structures can be further improved by employing suitable contact materials, amongst other factors such as modifying the solvent chemistries. The architecture reported in this work has potential applications towards building solar cells with solution processed 2D materials in the future.

Keywords: black phosphorus; MoS₂; liquid exfoliation; mechanical exfoliation; inkjet-printing; Raman spectroscopy; photoluminescence spectroscopy; p–n junction



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1. Introduction

The family of two-dimensional (2D) materials comprising graphene [1], MoS₂ [2,3], WSe₂ [4], and black phosphorus (BP) [5,6] have gained phenomenal interest in electronics, optoelectronic devices, sensors, and solar cells [7–11]. Among the various 2D materials, BP is a monoelemental van der Waals solid with a thickness-dependent direct bandgap which ranges from 0.3 eV in the bulk to about 2.0 eV for the single-layer BP flake [6,12]. The transistors fabricated from mechanically exfoliated BP are found to possess high ON/OFF ratios [13,14], and high mobilities (200–1000 cm² V^{−1} s^{−1}) at room temperature, compared to transition metal dichalcogenides (TMDs) [7,15]. Therefore, BP has attracted a great deal of attention for the research community and the electronics industry, to potentially use its exceptional properties in areas such as field-effect transistors (FETs) [16], photodetectors [17,18], and flexible optoelectronics [19–21]. Bulk BP, similar to other TMDCs, can be cleaved into its constituent layers through mechanical [22–24] or liquid-phase exfoliation [25,26]. Apart from the ability of liquid exfoliation to yield large quantities of nanosheets, it also has added advantages such as solution processability with the manufacture of devices on a wide variety of substrates, including in composite formats. In prior work [25], it was demonstrated that liquid exfoliation of BP by sonication in organic solvents, such as *N*-cyclohexyl-2-pyrrolidone (CHP), can stabilize the BP layer and provide a high yield of flakes. Compared with mechanically exfoliated BP sheets, liquid-phase

exfoliated BP is remarkably stable in CHP. It is anticipated that the tightly packed solvation shells in close proximity to the BP surface act as a protective barrier against moisture and oxygen that are known to deter the remarkable properties of BP [25]. With MoS₂, one of the most well-studied 2D TMDs, a thickness-dependent bandgap results that transitions from direct to indirect bandgap from 1.9 (monolayer) to 1.23 eV (bulk) [26].

Two-dimensional crystalline heterostructures created by stacking atomic layers of different materials on top of each other can push scaling limits of these materials by allowing the ability to form monolayer thick tunneling barriers and quantum wells [27]. Two-dimensional mechanically exfoliated vertical p–n junctions of BP–MoS₂ on oxidized Si wafers have already been studied, but there are no prior reports on liquid exfoliated and inkjet-printed BP–MoS₂ 2D p–n junctions on indium tin oxide (ITO) coated glass substrates, which would form a first step toward their integration into electronics and photovoltaics platforms. Recently, transistors made from the combination of inkjet-printed graphene and MoS₂ channel have shown good $I_{\text{on}}/I_{\text{off}}$ ratios of 336 [28]. Materials such as ITO serve as a good bottom contact for the device since it provides better adhesion, conductivity, and transmittance compared to other transparent conductive oxides with notable examples being zinc oxide (ZnO) and aluminum-doped zinc oxide (AZO) [29]. In solar cells, fore contacts must have n-type conductivity and thus ITO is used as a bottom contact to allow transmission of light into the solar cells while enabling electrical conductivity at the same time. The enhanced optical properties of ITO allow enhanced photocarrier generation since a large fraction of the incoming light can be transmitted through it [29].

The 2D p–n junction heterostructure can be stacked either vertically or laterally. The vertical architecture attracts the most attention because 2D materials can be easily stacked vertically due to minimal dangling bonds through the weak van der Waals interaction [30]. The band offset is also one of the critical parameters to be considered for designing 2D heterostructures. In a mono-epitaxial layer of graphene, Pierucci et al. [31] noticed the formation of miniband gaps. The miniband gaps are formed due to the periodic moiré pattern between the MoS₂ and graphene layers and band anticrossing occurring at the edge of the Brillouin zone [31]. The electrical transport characteristic at the interface of 2D/3D materials is governed by the thickness of the 2D material. Due to the formation of the metal–MoS₂ Schottky barrier, rectifying behavior is observed for few-layer MoS₂ on n–GaN substrates [32]. The van der Waals heterostructure alters the band alignment of graphene and other 2D materials [33], and in some cases the band edges shift up by 0.5 eV [34]. Inkjet printing is a versatile technique for the cost-effective and large-scale fabrication of heterostructures on a wide variety of substrates, unlike the mechanical exfoliation technique [35]. The flakes obtained by mechanical exfoliation are typically of better crystalline quality, but this technique is not scalable, but serves as a good reference for comparative analysis. On the other hand, inkjet-printing is scalable and well-tuned to large-scale manufacturability. It also allows tremendous flexibility to design structures such as sensor arrays and heterostructures of any geometry in both planar and vertical directions [36]. Inkjet-printing remains at the forefront amongst non-contact-digital fabrication technologies, offering the flexibility to print arbitrary design patterns at will, where the research has been translated to large-scale industrial applications [37]. Moreover, inkjet-printing has the capability to form individual pixels and is a material effective technique [38]. It has also been used to form arrays of molecular tunnel junction [39].

In this work, BP–MoS₂ 2D p–n junctions were formed and vertically stacked on top of each other using solution-processed inkjet-printing on a standard ITO glass substrate. The electrical behavior of the inkjet-printed BP–MoS₂ 2D p–n junction was evaluated and the electrical and optical behavior of individual layers was also examined. Moreover, we also compared the electrical behavior of mechanically exfoliated MoS₂ with that of the inkjet-printed MoS₂. This work should provide a good framework for using solution processed heterojunctions of MoS₂ and BP on ITO substrates for future solar cell platforms.

2. Materials and Methods

2.1. Liquid Exfoliation and Inkjet-Printing of Black Phosphorus Layer

The BP crystals were purchased from a commercial supplier (Smart-Elements) and stored in an Argon (Ar)-purged glovebox system where the oxygen and moisture levels were carefully controlled to be less than 0.1 ppm. The solvent used for the exfoliation was *N*-cyclohexyl-2-pyrrolidone (CHP), which was purchased from Sigma-Aldrich. The CHP solvent increases the oxidation resistance of BP by forming a solvation shell around it [25]. For liquid-phase exfoliation, BP crystal was finely ground into a powder form inside the glove box. The 60 mg of finely grounded powder was then mixed with 12 mL of CHP inside a conical tube filled with nitrogen (N₂) gas. The interface between the cap and the conical tube was sealed several times with Teflon tape and parafilm was found to be instrumental in preventing O₂ and H₂O to seep into the conical tube. The dispersion was sonicated for 24 hours under cooling in a Branson CPX 2800 bath sonicator (Fisher Scientific USA, Waltham, MA, USA) at ambient conditions. As-prepared BP dispersions were centrifuged at five different centrifugation rates ranging from 1000 up to 10,000 rpm for 10 min, using an Eppendorf Centrifuge 5804 (Hamburg, Germany) to remove bulk and unexfoliated BP layers. The 5 mL supernatant solution was taken out from the conical tube centrifuged at 1000 rpm for 10 min and transferred to the cartridge used for inkjet-printing. The viscosity of BP ink measured using the AMETEK DV3T Brookfield viscosity meter (Berwyn, IL, USA) was 10.82 cP, which is ideally tailored for inkjet printing with the Dimatix Fujifilm 2850 material printer (Santa Clara, CA, USA). The standard ITO glass substrates obtained from Sigma-Aldrich had a 120 nm thick ITO thin film and a surface resistivity of 8 ohms/sq. The substrate was cleaned by sonication in acetone, isopropyl alcohol (IPA), and deionized (DI) water for 5 min, followed by 15 min of UV ozone cleaning. The BP in CHP dispersion was inkjet-printed on the standard ITO glass substrate with a drop spacing of 20 μm and 40 passes were used to print the structures on top of each other. The BP layer was printed over a 5 mm by 3 mm rectangular area, and due to fluidic surface tension effects of the CHP ink with the ITO, the printed BP film took an elliptical shape with a smaller area. The printed BP film on the standard ITO glass substrate was then vacuum annealed at 70 °C for 30 min hold time, 250 °C for 90 min hold time, and 300 °C for 60 min hold time at a pressure of 5 m·Torr with a thermal ramp rate of 5 °C/min to evaporate the solvent and enhance the electrical conductivity.

2.2. Liquid Exfoliation and Inkjet-Printing of MoS₂ on Top of the BP Layer

The MoS₂ powder was purchased from Sigma-Aldrich. A mixture of cyclohexanone/terpineol (C/T) was used as an exfoliation solvent. Cyclohexanone was purchased from Acros organics and the terpineol was from Sigma-Aldrich. A mixture of 7 mL cyclohexanone and 3 mL terpineol was prepared by withdrawing the solvents using a micropipette and then 0.2 g of ethyl cellulose (EC) purchased from Sigma-Aldrich was mixed with the C/T mixture. The resultant mixture was sonicated for about 45 min until the EC completely dissolved in the C/T mixture. Ethyl cellulose is used as a surfactant that facilitates the exfoliation of MoS₂ into nanosheets by preventing the reagglomeration of the nanosheets and controlling the viscosity of the dispersion. The MoS₂ powder was then finely ground using a mortar and pestle and 300 mg of the finely grounded powder was mixed with the EC dissolved in the C/T solvent. The resultant dispersion was sonicated for 48 hours under cooling in a Branson bath sonicator at ambient conditions. The as-prepared dispersion was centrifuged in a conical tube at 1000 rpm for 10 min to remove bulk and unexfoliated MoS₂ layers. The 5 mL supernatant solution was then taken out from the conical tube and transferred to the cartridge used for inkjet-printing. The viscosity of the MoS₂ ink measured after centrifugation was 9.55 cP. The MoS₂ in the C/T dispersion was inkjet-printed on top of the BP layer with a drop spacing of 40 μm and again, 40 passes were used. The MoS₂ was printed over a square of 2 mm in length, but again due to fluidic surface tension effects with the C/T MoS₂ ink over the underlying BP layer, the printed MoS₂ layer was geometrically distorted from the designed parameters. The printed MoS₂

film on the BP layer was then vacuum annealed using the following thermal profile: ramp up to 120 °C for 40 min hold time, 220 °C for 20 min hold time, and finally 350 °C for 120 min hold time at 5 m-Torr of pressure at a ramp rate of ~5 °C/min in order to evaporate the solvent to form a densified film.

2.3. Mechanical Exfoliation of MoS₂ and Electron Beam Lithography to Form the Contacts

The 75 mm oxidized Si wafer was cleaved into a smaller 2 cm × 2 cm samples and then cleaned in acetone, IPA, and DI water for 5 min each, followed by surface treatment with UV ozone for 15 min. The MoS₂ bulk crystal was first exfoliated multiples times using blue-tac tape into thinner flakes until it was eventually transferred onto the oxidized Si wafer. The PMMA used for e-beam lithography was spin-coated on the exfoliated sample using a two-step process, where the first step is to uniformly coat the sample at 500 rpm initially, followed by a 1000 rpm/s for a duration of 10 s. In the second step, the solvent was evaporated at 1500 rpm, followed by a further increment to 2000 rpm/s for 60 s. Soft baking was conducted at 180 °C for 90 s to drive off the trapped solvents. The e-beam pattern was written using the JEOL JSM-7001F Scanning electron microscope (Peabody, MA, USA) and XENOS pattern generator (Waalwijk, The Netherlands) at a dose of 180 μC/cm² and 15 keV electron energy in a class 100 cleanroom. The pattern development was done by immersing the sample in a mixture of IPA and DI water at a ratio of 20:1 for 30 s. Metal electrodes comprising of 100 nm of Au were deposited over a 10 nm thick Ti adhesion layer using electron beam evaporation, using a metal lift-off process, where the underlying PMMA was dissolved with acetone in a squirt bottle.

3. Results and Discussion

To build the heterostructures, we first prepared the BP ink and inkjet-printed BP on the standard (std.) ITO glass substrate, so that the MoS₂ layer above printed thereafter protects the BP layer against oxidation. We sonicated the BP dispersion for 24 h with a nitrogen filled balloon surrounding the dispersion as shown in Figure 1a. Figure 1b depicts the color of the dispersion after sonication at various centrifugation speeds ranging from 2000 rpm, 5000 rpm, 8000 rpm, and 10,000 rpm was conducted for 10 min. The resulting stable BP dispersions possess a dark brown to yellow color, as seen in Figure 1c. The BP dispersion obtained after 24 h of sonication and centrifugation at 1000 rpm for 10 min. is seen in Figure 1d, which reveals a stable dark dispersion suitable for inkjet-printing.

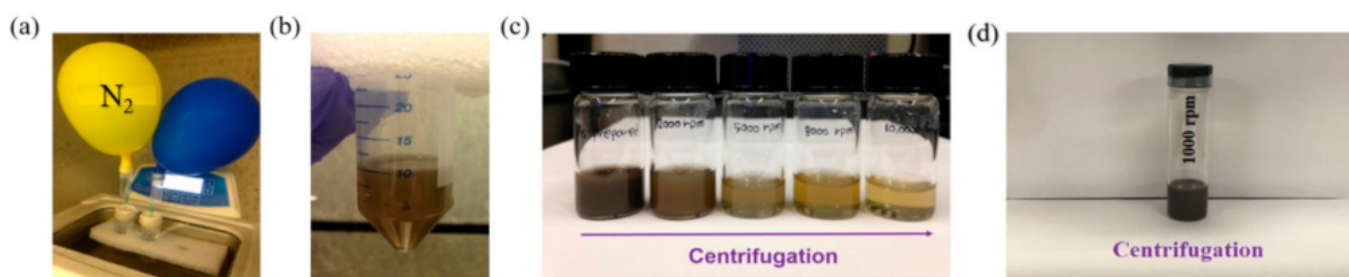


Figure 1. Liquid phase exfoliation of BP crystals. (a) Photograph of a BP dispersion in CHP during sonication using a N₂ filled balloon. Photographs in (b) of a BP dispersion in CHP after sonication at (c) different centrifugation conditions. In (c) the as-prepared dispersion is seen on the left followed by the solutions centrifuged at 2000 rpm, 5000 rpm, 8000 rpm, and 10,000 rpm are seen from left to right. (d) Photograph of BP dispersion in CHP after sonication using N₂ ambient balloon and centrifuged at 1000 rpm.

The scanning electron microscope (SEM) images and energy dispersive spectroscopy (EDS) elemental mapping of the layers were obtained using an FEI Quanta 200 Environmental (e-) SEM (Hillsboro, OR, USA). The Raman and photoluminescence (PL) data were obtained using a Horiba LabRAM HR Evolution (Kyoto, Japan), where the excitation laser wavelength used was 532 nm. Ultraviolet (UV)–visible (VIS) optical absorp-

tion spectroscopy was conducted using the CARY 5000 spectrophotometer (Oldsmar, FL, USA) in quartz cuvettes with 0.3 mL volumetric capacity. The electrical characteristics of the devices were measured with a micromanipulator 450PM-B probe stage equipped with an Agilent/Keysight precision semiconductor parameter analyzer 4156A (Santa Rosa, CA, USA). A Lakeshore CRX-4K probe station (Westerville, OH, USA) was used to obtain the I - V data for mechanically exfoliated flakes with a Keysight B1500-A semiconductor device analyzer.

The absorption spectrum of the BP flakes exfoliated in CHP followed by centrifugation at 1000 rpm is shown in Figure 2a in arbitrary units (a.u.), where the enhanced absorption at lower wavelengths corroborates the quantum confinement effects arising in the thinner BP platelets. The position of the absorption peak is dependent on the thickness of the BP layer. The absorption spectrum of the BP dispersion observed in this study is blue-shifted by 40 nm, i.e., the peak shifts from 260 nm as obtained in this study, compared to the absorption spectra of the bulk BP shown by Xu, et al. [40], where the peak was obtained at 300 nm, indicating the presence of few-layer black phosphorus. Raman and PL spectroscopy are powerful techniques to characterize various 2D materials. The optoelectronic properties of the black phosphorous and MoS₂ depend on their thicknesses [26]. In Figure 2b, the inkjet-printed BP shows the Raman peaks occurring at 361.0 cm⁻¹, 436.9 cm⁻¹, and 464.3 cm⁻¹ wavenumbers, which correspond to the locations of the A_g¹, B_{2g}, and A_g² phonon modes, respectively, for a few layers of BP. The B_{2g} and A_g² phonon modes vibrate in-plane, whereas the A_g¹ phonon modes vibrate out-of-plane for BP. The bottom-left inset in Figure 2b shows the optical microscope image of the BP flakes where the Raman and PL spectra were obtained, and the representation of the atomic arrangement of the three vibrational modes depicting the characteristic puckered structure of BP is illustrated in the top-left inset of Figure 2b.

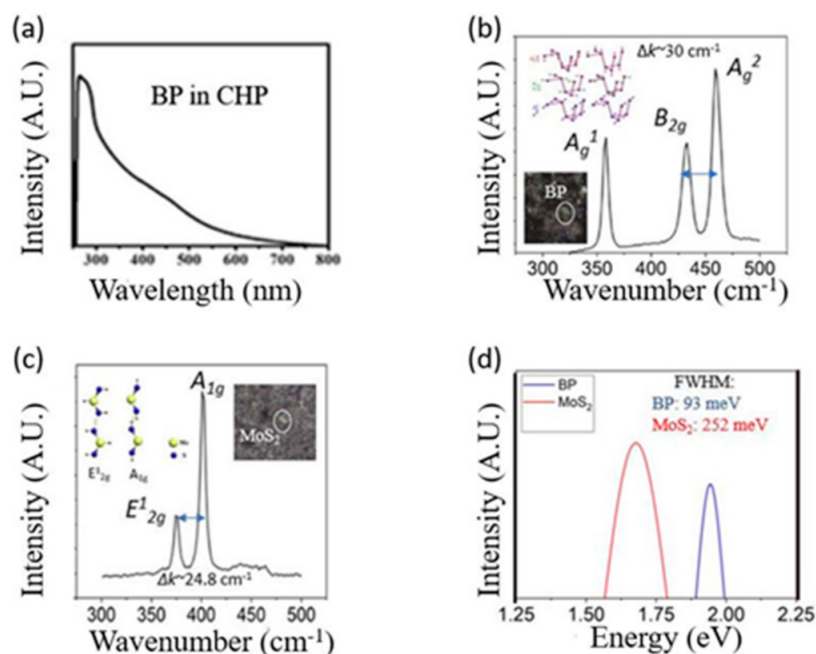


Figure 2. (a) Optical absorbance spectra of BP dispersed in CHP; (b) Raman spectra of inkjet-printed BP on std. ITO glass substrate with insets showing the optical microscope image with the location of the laser spot for the Raman measurements. The frequency shift between the two out-of-plane vibrational modes, B_{2g} and A_g², is 30 cm⁻¹ indicating few-layers of black phosphorus; (c) Raman spectra of inkjet-printed MoS₂ on top of BP with inset showing the optical microscope image and the location of the laser spot. The frequency difference between the in-plane and out-of-plane vibrational modes is 24.8 cm⁻¹ indicating multilayer MoS₂; (d) PL spectra and FWHM comparison of inkjet-printed BP and MoS₂ layers. All intensity are in arbitrary units (a.u.).

The number of atomic layers in the black phosphorus can also be characterized by the difference in frequency between the two out-of-plane vibrational modes, i.e., B_{2g} and A_g^2 modes. The frequency difference between the two out-of-plane vibrational modes Δk of the inkjet-printed black phosphorus, as shown in Figure 2a, is 30 cm^{-1} , which lies within that of bulk (27.7 cm^{-1}) and monolayer black phosphorus (31 cm^{-1}), and thus, we surmise that the inkjet-printed BP is at least a few layers thick [41]. Figure 2c shows the Raman spectra of inkjet-printed MoS₂ on top of the BP layer with the E_{2g}^1 and A_{1g} phonon vibrational modes with a wavenumber difference of 24.8 cm^{-1} . The right inset in Figure 2c shows the optical microscope image of the MoS₂ flake where the Raman and PL spectra were obtained, along with the MoS₂ structure in the left inset, where the Mo atom is sandwiched between the two S atoms. The E_{2g}^1 mode refers to the in-plane vibrations while the A_{1g} represents the out-of-plane phonon vibrations of the atoms in the MoS₂ crystal structure. Figure 2d depicts the PL spectra of inkjet-printed BP on the standard ITO glass substrate and inkjet-printed MoS₂ on BP. The bandgap of BP is 1.93 eV and that of MoS₂ is 1.68 eV indicating few-layers present for both materials. The full-width half maxima (FWHM) of BP were measured to be 93 meV and that of MoS₂ is 252 meV, which is about 2.7 times higher than that of the BP layer. The lower FWHM of BP compared to that of the MoS₂ is likely to arise from the more tightly bound atoms in BP's puckered structure compared to MoS₂ and the presence of a higher defect density in the latter, compared to BP [42].

The BP has an intrinsically p-type conduction whereas MoS₂ has an intrinsically n-type conduction as corroborated by prior studies [2,26]. Figure 3a shows the schematic cross-section of the inkjet-printed vertical 2D p–n junction heterostructure device where the layers are printed to form a stack. Figure 3b shows the optical micrograph of the inkjet-printed structure from the top. The irregularity in the printed structure is due to surface tension effects of the C/T MoS₂ ink with that of the CHP ink with BP. The darker region represents the MoS₂ whereas the brighter one represents BP. Figure 3c shows a top-view high magnification SEM image of the inkjet-printed overlying MoS₂ layer, where cluster like platelets uniformly appear to cover the BP layer underneath it. The EDS elemental distribution in Figure 3d taken over a $60\text{ }\mu\text{m} \times 60\text{ }\mu\text{m}$ area further confirms the presence of BP and MoS₂ layers along with the presence of indium, tin, and oxygen from the underlying ITO substrate.

Figure 4a shows the optical micrograph of mechanically exfoliated MoS₂ on the oxidized silicon substrate with Au/Ti contact electrodes on either end. Figure 4b shows the current–voltage characteristic of the mechanically exfoliated MoS₂ membrane probed on the oxidized Si wafer with the electron beam lithography (EBL) patterned electrodes as from Figure 4a. The interconnect spacing on the membrane was $5\text{ }\mu\text{m}$. The electrical behavior is mostly linear with some non-linearity at near-zero voltages. Figure 4c shows the electrical behavior of the inkjet-printed MoS₂ printed over 2 mm square on the oxidized silicon wafer, where the inset shows the optical image of the inkjet-printed MoS₂ on the oxidized Si wafer. The printed structure of the MoS₂ was almost the same geometry and dimensions as specified as opposed to the distorted geometry and dimensions of inkjet-printed MoS₂ on the underlying BP layer where the surface tension and viscosity of the CHP and C/T inks is in the printable range. As seen the MoS₂ printed on the BP layer has distorted geometry than the specified whereas the MoS₂ printed on the oxidized silicon substrate in printed with the same geometry as specified. The MoS₂ layer printed on the oxidized silicon substrate was printed with the exact dimensions as specified, this further reinforces our claim that the surface tension mismatch was the reason behind the distorted geometry of MoS₂ printed on BP layers since the surface tension of MoS₂ with C/T ink more closely matches with the oxidized silicon substrate as opposed to the BP with CHP ink.

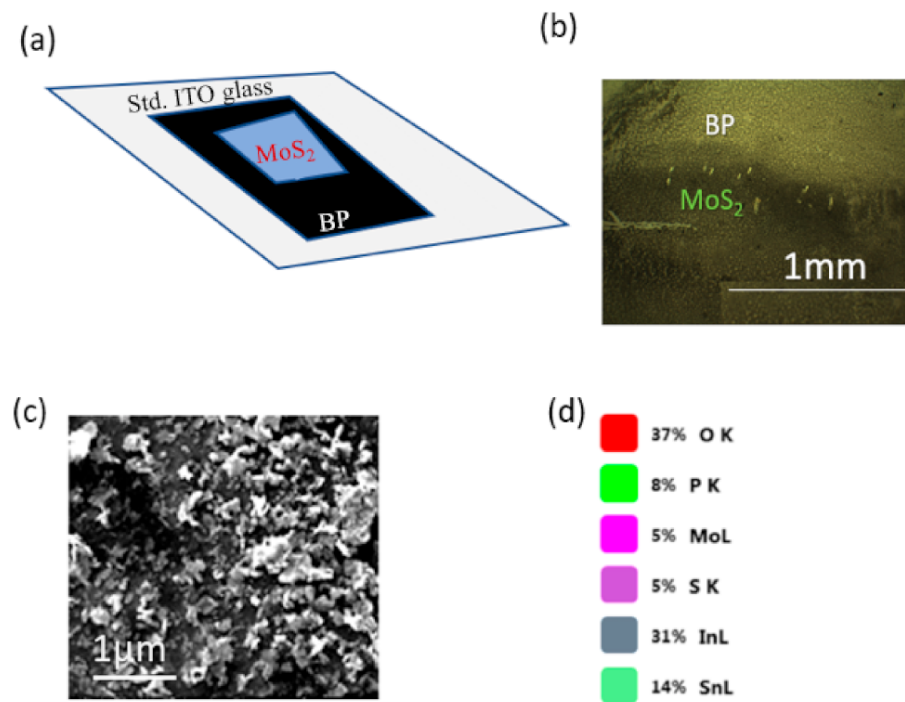


Figure 3. (a) Schematic of the aerial view of the device showing the heterostructure layers printed on top of each other; (b) areal view optical micrograph of the inkjet-printed MoS₂ on inkjet-printed BP on std. ITO glass substrate; (c) SEM micrograph (aerial view) of inkjet-printed MoS₂ on inkjet-printed BP on std. ITO glass substrate indicating uniform dispersion of MoS₂ over BP; (d) EDS elemental distribution of the corresponding to the region of the SEM image in (c) taken over an area spanning 60 μm × 60 μm and indicating the presence of P, Mo, S, In, Sn, and O from the underlying layers on the ITO substrate.

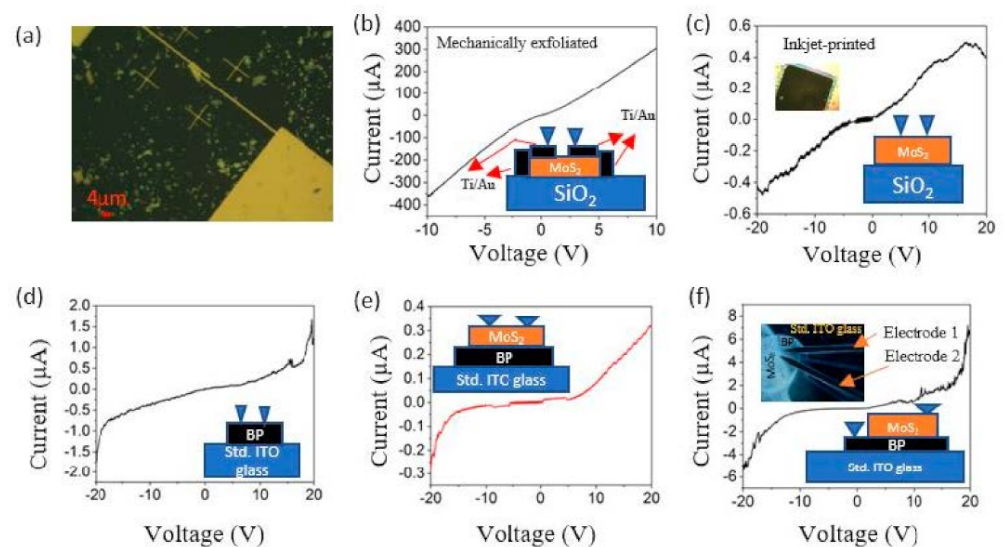


Figure 4. (a) Optical micrograph of the EBL patterned MoS₂ flake with Au/Ti contacts at 50× magnification; electrical characterization of (b) the mechanically exfoliated MoS₂ flake on silicon dioxide substrate with EBL patterned Au/Ti contacts; (c) inkjet-printed MoS₂ on the silicon dioxide substrate with the inset showing an optical image of the printed structure; (d) inkjet-printed BP on std. ITO glass substrate; (e) inkjet-printed MoS₂ on top of the BP layer; (f) inkjet-printed BP-MoS₂ junction with the inset showing the probe locations across both the layers.

The electrical behavior of the inkjet-printed MoS₂ on the oxidized Si wafer in Figure 4c was obtained by direct probing the layer where the probe spacing was 200 μm. Reducing the spacing of the probes did not increase the magnitude of the current, on the contrary, the current magnitude further decreased, which could be due to the non-uniform topography of the printed structure. Compared to the inkjet-printed MoS₂ on the oxidized Si wafer, the magnitude of the current was about 1000 times higher for the mechanically exfoliated MoS₂ flake at the same voltage. The electrical behavior of the mechanically exfoliated and contacted flake shows nearly ohmic characteristics due to the ohmic contacts formed by the 100 nm Au over the 10 nm Ti (adhesion layer) with MoS₂. Moreover, the inkjet-printed structure has some noise in the current–voltage characteristic whereas the mechanically exfoliated flake shows a smooth curve. The superior electrical characteristic of the mechanically exfoliated flake is due to the higher crystalline quality of the mechanically exfoliated flake and the excellent interface quality of the metal contact and the flake. On the contrary, the relatively poor electrical characteristic of the inkjet-printed MoS₂ layer is due to the defects induced during the exfoliation process and trapped residual solvent and surfactant.

The quasisymmetric non-linear behavior observed in the inkjet-printed BP and MoS₂ layers in Figure 4d,e is due to the Schottky barrier formed at the interface of the tungsten electrode probes and BP and MoS₂ layers. Due to the relatively higher trap states and defect densities in the inkjet-printed MoS₂ compared to inkjet-printed BP and a higher Schottky barrier height at the interface of MoS₂ and the tungsten probes compared to BP and tungsten probes, the current almost remains constant until moderate voltages have been built up in the MoS₂; however, at high voltages there is sufficient energy for the electrons to be able to tunnel through the barrier and conduct, and so, the current increases steeply after that.

Figure 4f shows the electrical behavior across the BP–MoS₂ p–n junction interface. The device shows a non-ideal diode-like character. The rectification ratio was obtained by taking the modulus of the ratio of forward current and reverse current at ±20 V. The rectification ratio is given as $I_{\text{fwd}}/I_{\text{Rev}}$ [32]. The rectification ratio obtained was 1.137. The ideality factor of this p–n junction was calculated using the equation: $\eta = \frac{q}{kT} \times \frac{dV}{d \ln I}$ [43], where q is the charge of electron, i.e., 1.6×10^{-19} C, T is 300 K, assumed to be room temperature, and $\frac{dV}{d \ln I}$ is the slope of the voltage versus natural log of current. The ideality factor obtained after the calculation was 8.88, which indicates the inkjet-printed p–n junction considerably deviates from the ideal diode equation. The rectification ratio obtained in this study is about three orders of magnitude less than the one reported by Deng, Y. et al. [44], where devices were made using mechanically exfoliated BP–MoS₂ 2D p–n junction as opposed to the liquid exfoliated and inkjet-printed BP–MoS₂ heterojunctions in this study. The lower rectification ratio observed in this study is likely due to the ultra-thin size of the flakes in the liquid exfoliated and inkjet-printed structure compared to the mechanically exfoliated flakes resulting in increased dominance of electrons tunneling across the barrier at the interface of BP and MoS₂ [45]. A slightly high value of ideality factor indicates the possibility of the charge traps and defect densities across the BP–MoS₂ interface, which may have occurred due to the interdiffusion of the layers across the interface during the vacuum annealing step. The ideality factor can be further reduced by improvising on the contact materials for the BP and MoS₂ layers, which can minimize the detrimental effects due to interfacial trap states.

4. Conclusions

We demonstrated the inkjet-printed BP–MoS₂ vertical 2D p–n junction on std. ITO glass substrates, where a comparison of the electrical behavior of the inkjet-printed MoS₂ with that of the mechanically exfoliated MoS₂ flake was made. The superior electrical behavior of the mechanically exfoliated MoS₂ is due to the superior crystalline quality of the flake compared to the liquid exfoliated and inkjet-printed MoS₂ layer and high-quality contacts resulting in reduced interfacial defects. The lower rectification ratio observed in the BP–MoS₂ 2D p–n junction is due to the ultra-thin flakes. The ideality factor of the

junction can be further reduced through contact engineering to minimize the effect of interfacial trap states. The inkjet-printed vertical architecture demonstrated has potential applications in the future towards solar cell platforms.

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